




IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Kim et al.
Serial No.: 10/032,687
Filed: December 28, 2001
For: METHOD OF FORMING
WIRING IN
SEMICONDUCTOR DEVICES
Group Art Unit: 2822
Examiner: Maria F. Guerrero

I hereby certify that this paper is being
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January 30, 2004


James P. Zeller
Reg. No. 28,491

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PETITION UNDER 37 C.F.R. §1.136(a)

Commissioner for Patents
P.O. Box 1450
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Sir:

Applicants, by their attorneys, petition for a one-month extension of time to file a
response to the official action of October 3, 2003.

Submitted herewith is the one-month extension fee of \$110.00.

Any additional required fee may be charged or any overpayment credited, to our

Deposit Account No. 13-2855.

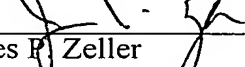
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Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

January 30, 2004

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